

Notice of References Cited	Application/Control No. 10/757,392		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner LEONARD J. WEINSTEIN		Art Unit 3746	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,655,924 B2	12-2003	Ma, Qing	417/209
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	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.